

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/767,009	YAMAMOTO, MIKA	
Examiner	Art Unit	
Douglas Q. Tran	2624	

	SEARCHED					
Class	Subclass	Date	Examiner			
358	1.1 - 1.18	10/12/05	olt			
			,			

INI	INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner			
		·				

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
East Search NPL (IEEE)	10/12/05	- alt
		· ·
	·	